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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Art Unit: **2815**

Application Number: **10/743,793**

Examiner: **Jay C. Kim**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING METHOD
THEREOF**

Attorney Docket Number: **032206**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 30, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 2, 2008 for one month from December 2, 2008 to January 2, 2009.

Attached, please find our payment including the amount of \$130.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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